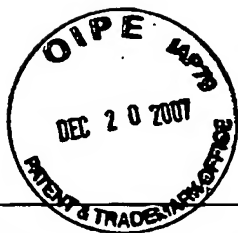


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name of person signing certification

Michael S. Huppert

December 18, 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|-------------------------|---|--------------------------------|
| In re application of | : | Confirmation No. 5135 |
| Atuhito MOCHIDA et al. | : | Attorney Docket No. 2003_1798A |
| Serial No. 10/730,982 | : | Group Art Unit 1725 |
| Filed December 10, 2003 | : | Examiner Kiley Shawn Stoner |
| A METHOD OF MOUNTING A | | Mail Stop: AF |
| SEMICONDUCTOR LASER | | |
| COMPONENT ON A SUBMOUNT | | |

AMENDMENT AFTER FINAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 18, 2007, please amend the above-referenced U.S. patent application as follows: